REPORT DOCUMENTATION PAGE

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13. SUPPLEMENTARY NOTES

Presented at Mirror Technology Days, Boulder, Colorado, USA, 7-9 June 2010.

14. ABSTRACT

Our recent work related to closed-loop electrostatic control of membrane mirrors is summarized in this presentation. We begin with a short description of electrostatic actuation as applied to membrane mirrors, and follow this up with a brief overview of the possible actuation control approaches. The main focus of this presentation is on the two techniques being studied in our laboratory: (1) area control, which involves switching control of conductor segments forming suitably located electrode clusters, and (ii) gap control, which consists of mechanical control of the electrode-membrane gap via a movable electrode substrate. Closed loop control strategies are investigated that provide deflections and bandwidths in the range of 60 micrometers and 500 Hz respectively. A Lyapunov potential method is used for stable tracking of trajectories consistent with these deflection-bandwidth criteria. While our initial emphasis is on small single-mode focus/defocus and tip/tilt mirrors, the method generalizes without much difficulty to multiple-mode actuation of larger mirrors. Results discussed here include time domain simulations and experiments on the closed-loop dynamics of single-mode mirrors under area and gap control, and static tests illustrating gap control of multiple-mode mirrors.

15. SUBJECT TERMS

Electrostatic actuation, Membrane mirrors, Large deflection and bandwidth, Closed loop dynamics, Lyapunov method, Area control, Gap control.

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Closed Loop Electrostatic Actuation of Membrane Mirrors

Miles A. Wickersham, Brian C. Fehrman, Umesh A. Korde (PI)

Advanced Dynamics Lab, Mechanical Engineering, South Dakota School of Mines and Technology (SDSMT)

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Mirror Technology Days in Government, June 7-9, 2010



Outline

Introduction

Area Control
Single Mode Actuation
Multiple Mode Actuation

Gap Control

Conclusion





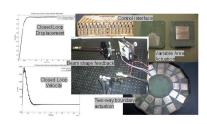
Membrane Mirror Actuation (Not an SBIR/STTR Project)

Innovation

 Development of a dynamically controlled actuation system for membrane mirrors

Accomplishments

- Low-moderate voltage, large deflection, large-force electrostatic actuation
- Variable-area, variable-gap techniques developed
- Closed loop, current bandwidth → 500 Hz.



Government/Science Applications

- Laser and microwave communication
- Nonlinear control with optics feedback



Introduction

- ► Large deformable reflectors
 - large actuation authority desirable (i.e, large forces and/or deflections)
- Membrane reflectors (monolithic, conformable, deployable)
 - slow natural response vs. need for greater bandwidths
 - aberration corrections (atmospheric turbulence, slewing dynamics-structural coupling)
 - process requirement (e.g. communication)
- Electrostatic actuation well suited for force and deflection authority requirement





Introduction

Voltage difference between 2 conductors causes force



$$F = \frac{\varepsilon V_a^2 A}{2G_0^3 (1 - X)^2}; \quad \left(X = \frac{x}{G_0}\right) \tag{1}$$

where V_a is the voltage across the electrode, A is the area of the active electrode, and ε is the permittivity, here, of air.

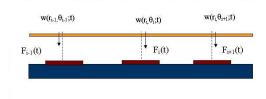
 Active electrode on fixed substrate, metallized membrane provides the neutral electrode



Membrane Actuation

Introduction

- ▶ To produce deflection $w(r, \theta; t)$ at any point, apply force $f(r, \theta; t)$. The force distribution over the membrane could be controlled in real time by controlling
 - voltage on the active electrodes
 - area of the active electrodes.
 - gap between the individual active electrodes and membrane







Membrane Actuation (II)

- Voltage control
 - commonly used and intuitive
 - high voltages for large deflections
 - closed-loop control requires accurate manipulation of large voltages
- Area control
 - Segmented active electrodes
 - switching on/off segments to control active area
 - constant voltage
 - closed-loop control now a switching problem
- ► Gap Control
 - multiple aberration modes using a single control input
 - actuate substrate mechanically; constant voltage, constant area control
 - continuous control



- ▶ Voltage control methods: Zhu et al. (2007), Maithripal et al. (2006), Seeger et al. (2004); closed loop control necessary for deflections $> \frac{1}{3}$ gap size.
- ▶ Area control and gap control: results discussed here
- Results published in Korde (2008, 2009, 2010)¹

J. Intelligent Material Systems and Structures, v. 19, n. 11, pp. 1339-1359



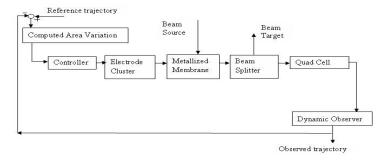
Introduction

¹J. Intelligent Material Systems and Structures, v. 21, January 2010, pp. 61-82

J. Intelligent Material Systems and Structures, v. 20, n. 6, 2009, pp. 697-721

Single Mode Actuation

Single Mode Control



- ▶ Deflection range at mirror center \rightarrow full gap size G_0 (40 μ m here),
- ▶ Tip/tilt deflection \rightarrow maximum allowed by G_0 (3 mrad here),
- Response bandwidth of 500 Hz.



Single Mode Control (II)

Dynamics (Lumped Parameter Model)

$$\dot{X}_e = V_e$$

$$\dot{V}_e = -KX_e - DV_e + \frac{\varepsilon V_a^2}{2G_0^2 (1 - X_e)^2 m_e} A(t)$$
 (2)

- Nonlinear system
- ▶ Mass m_e, stiffness K and damping D from energy considerations



Closed Loop Actuation

Single Mode Control (III)

Area Control





Mirror for single-mode 2-way actuation



Single Mode Control (IV)

 Specify reference trajectory for mirror deflection for focus/defocus or tip/tilt beam deflection

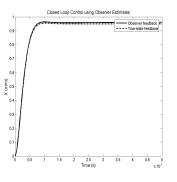
Area Control

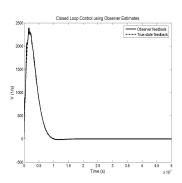
- Compute corresponding reference area variation and discretize to minimum segment area
- Dynamic observer design based on quad cell input
- Lyapunov potential method for variable gain controller design for trajectory tracking





Single Mode Control Results (I)



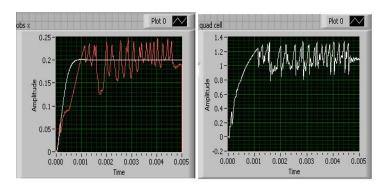


Simulation results: discrete area control with observer feedback





Single Mode Control Results (II)



Experimental results: discrete area control with observer driven by quad-cell measurements

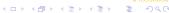


Multiple Mode Actuation

Multiple Mode Actuation (I)

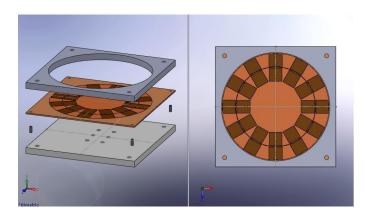
- ▶ Up to 12 aberration modes
- Bandwidth of 500 Hz
- ► Center deflection $\pm 100 \mu$ m
- Electrostatic actuators placed along boundary
- Mirror surface metallic
- Closed loop control
- Possible with area control or gap control





Multiple Mode Actuation

Multiple Mode Actuation (II)

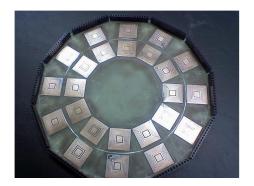




Mirror design



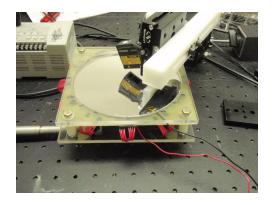
Multiple Mode Actuation (III)



Mirror actuator clusters for variable area control



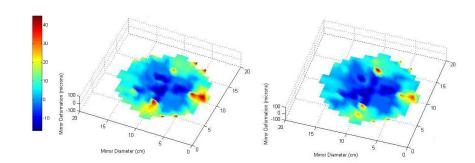
Multiple Mode Actuation (IV)



Completed mirror undergoing static tests



Multiple Mode Actuation (V)



Excitation with 260 V (Left) and 280 V (Right)





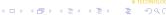
Gap Control: Basic Features

Mechanical or piezoelectric control of electrode gap

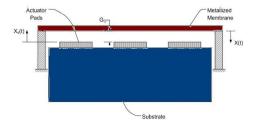
Gap Control

- ► Single control variable for multiple-mode actuation
- Constant voltage on constant-area electrodes
- Potentially large number of aberration modes
- Switch on/off selected actuators to determine aberration modes corrected for





Gap Control Schematic



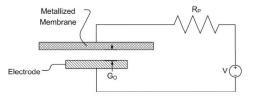
Substrate is driven mechanically/piezoelectrically; single control variable $x_s(t)$.





Gap Control

Gap Control Goals



- Bandwidth of 500 Hz.
- ▶ Target deflection 60 μ m
- Trajectory tracking in the presence of random measurement error and random platform vibration





Nondimensionalized equations of motion

$$\dot{x} = v
\dot{v} = -2\zeta\omega_0 v - \omega_0^2 x + \frac{1}{3}q^2\omega_0^2 + u
\dot{q} = \frac{1}{R_p C_0} \left(-q(1-x) + \frac{2}{3}V \right)$$
(3)

u is the control variable given by

$$-G_0 u \equiv -\ddot{x}_s - \frac{b}{m_e} \dot{x}_s - \frac{k_e}{m_e} x_s$$

where x_s denotes the displacement through which the substrate is driven.

Gap Control

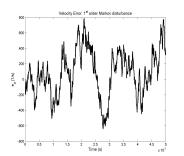
Control Approach

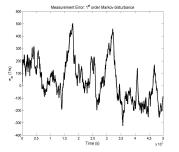
- Reference trajectory for mirror corresponding to deflection and bandwidth
- Corresponding reference trajectory for gap variation
- Closed loop control to keep actual motion on reference trajectory
- Dynamic observer
- Lyapunov potential method
- Controller design to ensure velocity errors → 0 in the presence of measurement error and platform vibration.
- Measurement error and platform vibration assumed to be 1 st order Markov processes



Control against measurement error and platform vibration

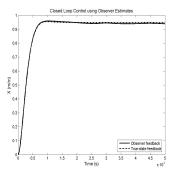
- Errors in sensor measurements used in feedback
- Taken to be random but band-limited; 1st order Markov process
- Platform (e.g. air/space vehicle) where mirror is mounted subject to vibration
- Taken to be band-limited; also 1st order Markov process

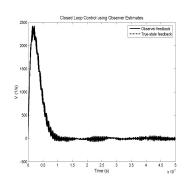






Gap control results





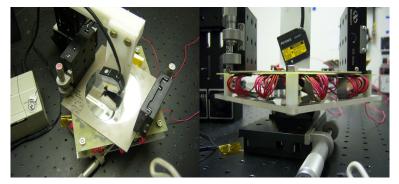
Gap Control

Simulation results; Close trajectory tracking with closed loop control based on dynamic observer estimates; random measurement error and platform vibration



Gap Control: Measurements

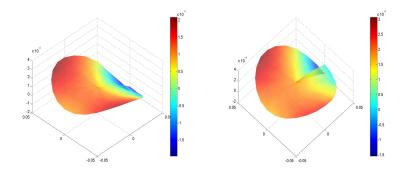
Static measurements



Static tests; surface measurements on the boundary-actuated mirror using a laser displacement sensor.



Gap Control: open loop static measurements



$$\textit{G}_0 = 69 \mu \text{m}$$
 (Left) and $\textit{G}_0 = 129 \mu \text{m}$ (Right)

Open loop static tests; all actuators on (at 500 V); focus/defocus mode.



- Two methods examined for electrostatic control of membrane reflectors
- Area Control
 - closed loop control a switching problem
 - precise control seen in simulations
 - oscillations seen in experimental results
- Gap Control
 - continuous control
 - precise control in presence of measurement error and platform vibration
 - concept shown to work in static open loop tests
 - dynamics experiments underway
- ▶ Bandwidth, deflection requirements met in both cases



- ▶ Air Force Research Laboratory, Space Vehicles Directorate (AFRL/RV)
- Jeremy Banik, Program Manager
- ▶ Lisa Robinson, Andrew Downs at Advanced Dynamics Lab, South Dakota School of Mines and Technology



